

## Introduction

Organizing nanoparticles on surfaces in an ordered manner is crucial for their use as active components in functional devices. However, patterning colloidal nanoparticles into a predefined structure with nanometre precision and scalability remains a significant challenge. Our work presents a combinatory approach that is fast, reliable, and scalable to solve this issue by forming ordered patterning of nanomaterials on the substrate. We form a metallic nanostructure using nanosphere lithography as the master substrate and trap the nanoparticles above it using Dielectrophoresis. Here, the formation of the master substrate and a simulation study to demonstrate the trapping ability of the aforementioned method is presented

## Dielectrophoresis (DEP) trapping

- It is the motion of a particle caused by polarization effects in a non-uniform electric field

$$\text{DEP Force, } \langle F_{DEP} \rangle = 2\pi r^3 \epsilon_m \text{Re}[f_{cm}] \nabla E^2, \quad f_{cm} = \frac{\tilde{\epsilon}_p - \tilde{\epsilon}_m}{\tilde{\epsilon}_p + 2\tilde{\epsilon}_m}$$

Where,  $r$  is the radius of the particle,  $\epsilon_m$  is the permittivity of the medium, and  $f_{cm}$  is the Clausius-Mossotti factor

$\tilde{\epsilon}_p$  and  $\tilde{\epsilon}_m$  are the complex permittivity of the particle and the medium respectively

- Dielectrophoresis (DEP) can be used effectively for the formation of arrays of colloids or pattern formation due to its ability to manipulate particles with precision.
- Depending on the electrode geometry, different particle formations can be achieved (chains, bridges etc.) and particles can be placed on desired location based on positive dielectrophoresis (pDEP) or negative dielectrophoresis (nDEP).

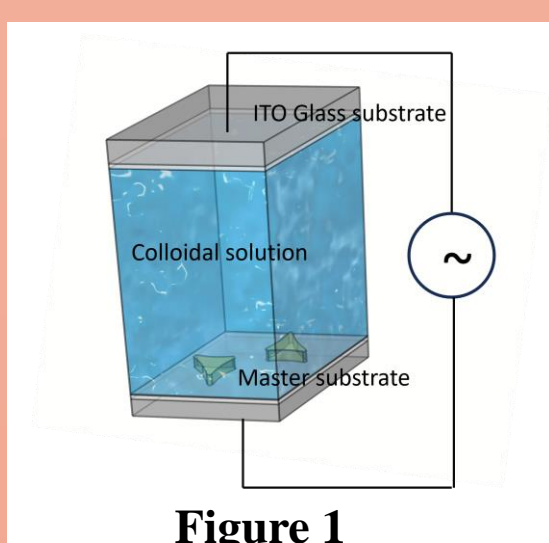


Figure 1

- The experimental setup for DEP trapping is a top-bottom electrode with 10  $\mu\text{m}$  gap applied by an AC field. The master substrate, which is formed from NSL, serves as the bottom electrode while a plane ITO substrate is the top electrode. Figure 1 shows the unit cell used for the DEP trapping simulation study

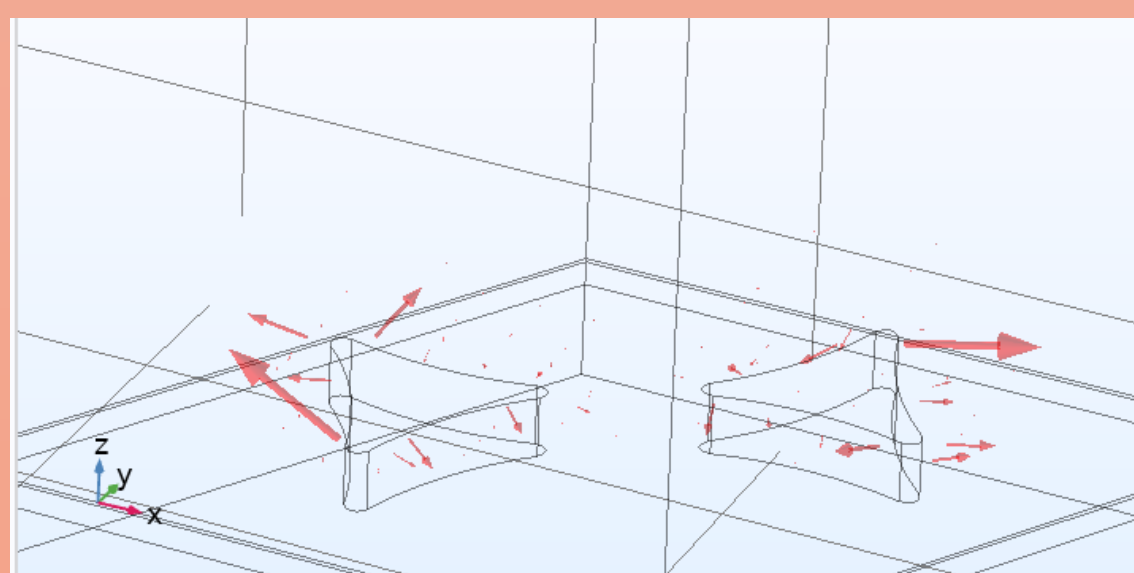


Figure 2 : Shows direction and magnitude of DEP force acting on 40 nm colloidal particle at  $z=75\text{nm}$  (close to the gold nanotriangles)

- The edges and tips of the nanotriangles produce higher field gradients compared to flat surfaces, making them ideal for exerting DEP forces on nearby particles
- The patterned surface allows for multiple particles to be trapped simultaneously at different nanotriangle sites

## Results

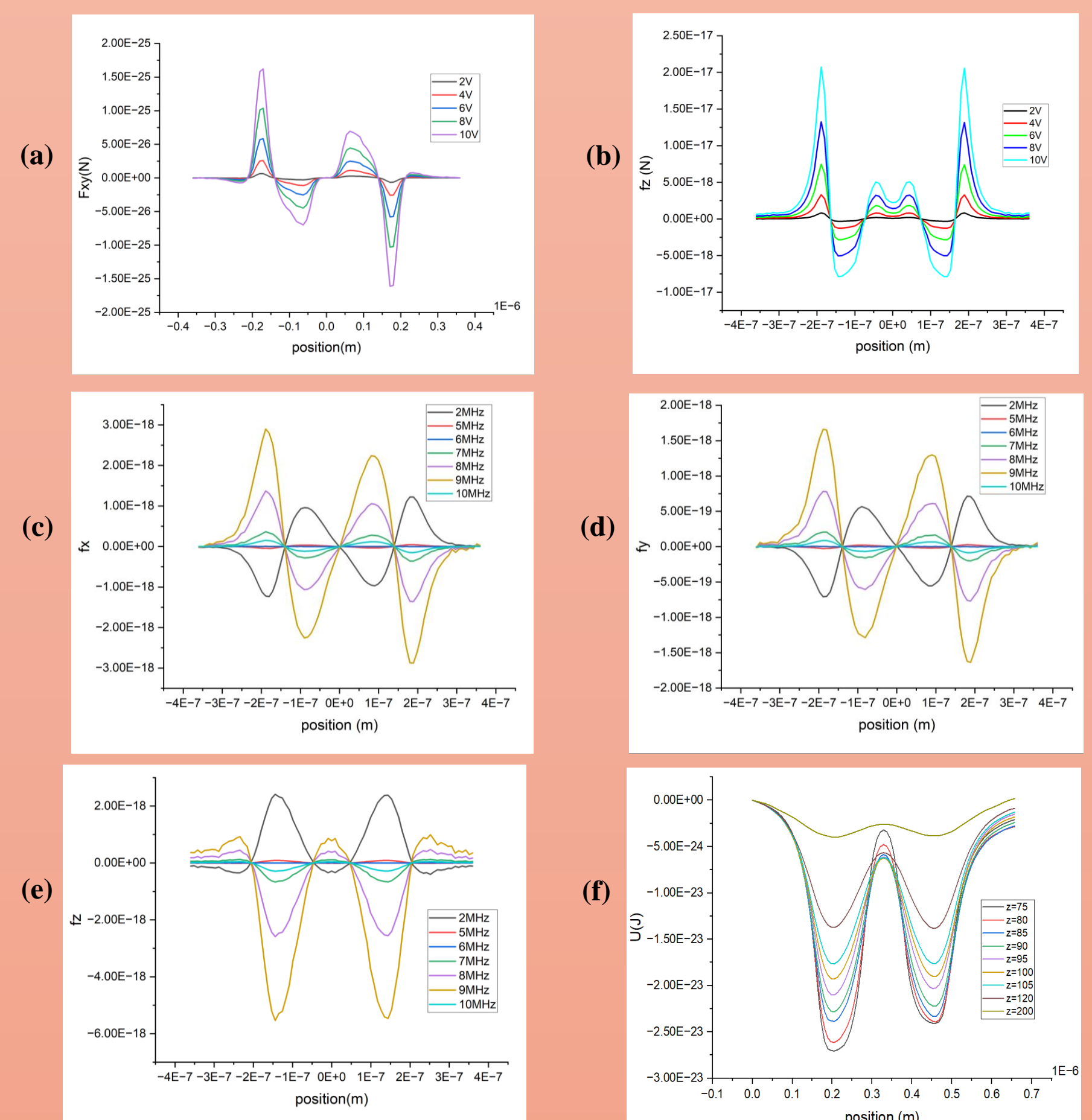


Figure 4: (a) and (b) shows variation of force with respect to voltage (c),(d) and (e) shows variation of force with respect to frequency and (f) variation of potential energy with height of the particle from the surface of the substrate

- Time-averaged DEP force acting on a spherical particle was calculated using Maxwell Stress Tensor method (MST)
- According to the simulation results, 40 nm sized colloidal particle that are closer to the surface of the electrode can be trapped at the surface when supplied with an AC current of voltage 10V and 9MHz frequency using the top-bottom electrode

## Preparation of master substrate- Nanosphere Lithography (NSL)

- NSL is an inexpensive, simple, high throughput technique to form nanoparticle structure and well-ordered 2D arrays of nanoparticles. This involves the following steps:
  - Formation of polymer mask using monodispersed colloidal polystyrene beads of size 600 nm (Figure (a) and (b)).
  - Hexagonal nanotriangles formed by thermal evaporation of 40 nm gold over the polymer mask followed by ultrasonication to remove the mask

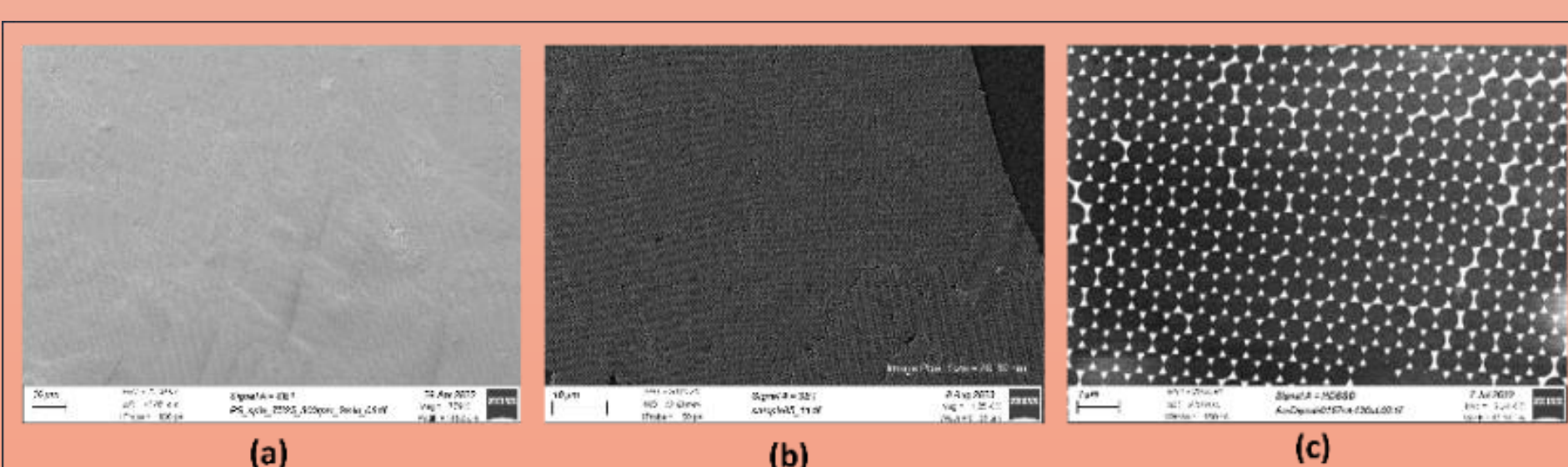


Figure 3: Polymer mask formed by (a) drop casting (b) convective assembly (c) Gold nanotriangles

## Conclusion

A combinatory approach that is fast, reliable, and scalable by combining NSL and Dielectrophoresis to form ordered arrangement of nanoparticles is presented here.

## Future works

Experimentally prove the trapping of colloidal particles using top and bottom electrodes by capturing a video of the trapped particle and conducting a statistical analysis.

## Reference

- G. Petit, R. Hernandez, S. Raffy, A. Cuche, L. Soria Marina, M. D'Amico, E. Palleau, and L. Ressler, "Electrostatically Driven Vertical Combinatorial Patterning of Colloidal Nano-Objects," *Colloids and Interfaces* 7(1), (2023).
- X. Xing, Z. Man, J. Bian, Y. Yin, W. Zhang, and Z. Lu, "High-resolution combinatorial patterning of functional nanoparticles," *Nat Commun* 11(1), 1–8 (2020).
- M. Punjiya, H. Rezaei Nejad, J. Mathews, M. Levin & S. Sonkusale "A flow through device for simultaneous dielectrophoretic cell trapping and AC electroporation," *Scientific Reports* volume 9, Article number: 11988 (2019)